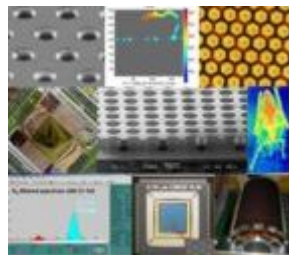


## **Session Program**

**16-18 Apr 2008**



# **Micro-Pattern Gas Detectors (RD51) Workshop**

## ***New Technology II***

NIKHEF, Amsterdam

# Wednesday 16 April

10:50

## New Technology II

Session | Location: NIKHEF, Amsterdam | Convener: Leszek ROPELEWSKI

10:50–11:20 **Micromegas**

**Speaker**

Ioanis Giomataris

11:20–11:40 **Large GEM detectors development**

**Speaker**

Serge Duarte Pinto

11:40–12:00

**Latest achievements in developments of large-area screen printed resistive GEMs**

**Speaker**

Vladimir Peskov

12:00–12:20 **Ion back flow reduction in GEM-like cascades operating in HpXe**

**Speaker**

Joao F.C.A. Veloso

12:20–12:40

**Efficient ion blocking in patterned hole-multipliers and its application to visible-sensitive gas-avalanche photomultipliers**

**Speaker**

Amos Breskin

12:40